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Attorney Docket No. 108298726US  
Disclosure No. 03-0128.00/US

PTO/SB/21 (09-04)  
Approved for use through 07/31/2006. OMB 0651-0031  
U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

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<b>TRANSMITTAL FORM</b>  (to be used for all correspondence after initial filing)	Application Number	10/687,458-Conf. #8780	
	Filing Date	October 15, 2003	
	First Named Inventor	David J. Kubista	
	Art Unit	1763	
	Examiner Name	Rudy Zervigon	
Total Number of Pages in This Submission	17*	Attorney Docket Number	108298726US

ENCLOSURES (Check all that apply)		
<input type="checkbox"/> Fee Transmittal Form  <input type="checkbox"/> Fee Attached  <input type="checkbox"/> Amendment/Reply  <input type="checkbox"/> After Final  <input type="checkbox"/> Affidavits/declaration(s)  <input type="checkbox"/> Extension of Time Request  <input type="checkbox"/> Express Abandonment Request  <input checked="" type="checkbox"/> Information Disclosure Statement  <input type="checkbox"/> Certified Copy of Priority Document(s)  <input type="checkbox"/> Reply to Missing Parts/Incomplete Application  <input type="checkbox"/> Reply to Missing Parts under 37 CFR 1.52 or 1.53	<input type="checkbox"/> Drawing(s)  <input type="checkbox"/> Licensing-related Papers  <input type="checkbox"/> Petition  <input type="checkbox"/> Petition to Convert to a Provisional Application  <input type="checkbox"/> Power of Attorney, Revocation Change of Correspondence Address  <input type="checkbox"/> Terminal Disclaimer  <input type="checkbox"/> Request for Refund  <input type="checkbox"/> CD, Number of CD(s) _____  <input type="checkbox"/> Landscape Table on CD	<input type="checkbox"/> After Allowance Communication to TC  <input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences  <input type="checkbox"/> Appeal Communication to TC (Appeal Notice, Brief, Reply Brief)  <input type="checkbox"/> Proprietary Information  <input type="checkbox"/> Status Letter  <input checked="" type="checkbox"/> Other Enclosure(s) (please identify below): Certificate of Mailing Form PTO/SB/08 Cited References (64 enclosed) Return Receipt Postcard
<div>Remarks</div>		

SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT			
Firm Name	PERKINS COIE LLP		
Signature			
Printed name	David T. Dutcher		
Date	April 11, 2005	Reg. No.	51,638

\* Number of pages does not include cited references



Attorney Docket No. 108298726US  
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(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Kubista et al.

Application No.: 10/687,458

Confirmation No.: 8780

Filed: October 15, 2003

Art Unit: 1763

For: **SYSTEMS FOR DEPOSITING MATERIAL  
ONTO WORKPIECES IN REACTION  
CHAMBERS AND METHODS FOR  
REMOVING BYPRODUCTS FROM  
REACTION CHAMBERS**

Examiner: Rudy Zervigon

**INFORMATION DISCLOSURE STATEMENT (IDS)**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is filed before the mailing date of a first Office Action on the merits as far as is known to the undersigned (37 CFR 1.97(b)(3)).

A copy of each Non-U.S. Patent and each Non-Patent Literature article listed on the PTO/SB/08 is attached. A copy of the U.S. Patents listed on the PTO/SB/08 has not been provided. A full translation of the non-English language references marked by a

check mark (✓) is enclosed. An abstract is enclosed for all other non-English language references. Applicant has not verified that the translation or abstract is an accurate representation of the teachings of the non-English reference, though, and reserves the right to demonstrate otherwise.

In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. In accordance with 37 CFR 1.97(h), the filing of this Information Disclosure statement shall not be construed to be an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 50-0665, under Order No. 108298726US.

Dated: April 11, 2005

Respectfully submitted,

By 

David T. Dutcher

Registration No.: 51,638

PERKINS COIE LLP

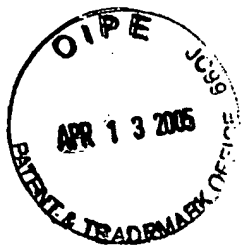
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<b>Substitute for form 1449A/B/PTO</b>  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (Use as many sheets as necessary)				<b>Complete If Known</b>	
				Application Number	10/687,458-Conf. #8780
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				Art Unit	1763
				Examiner Name	Rudy Zervigon
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U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
		US-10/767,298	Filed 01-28-2004	Zheng et al.	
		US-11/027,825	Filed 12-29-2004	Derderian et al.	
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Examiner Signature		Date Considered	
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Sheet	4	of	13	Attorney Docket Number	108298726US

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Sheet	5	of	13	Attorney Docket Number	108298726US

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Sheet	6	of	13	Attorney Docket Number	108298726US

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Sheet	7	of	13	Attorney Docket Number	108298726US

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